Carnegie Mellon University Mechanical Engineering

Estimating Poses with Confidence in Robotic Metrology for Additively Manufactured Parts

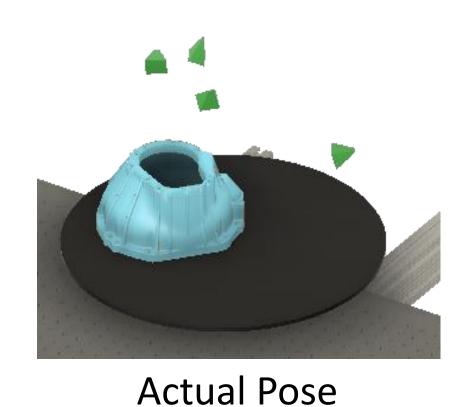
Introduction

Goal

The project aims at developing a **Robotic** Metrology pipeline for high precision scanning of additively manufactured parts.

The objective of the pose estimation module within the metrology pipeline is to accurately determine the spatial orientation and position of components.





Required Pose

Motivation

- Viewpoint Planning is **dependent on the pose** of the object in the simulation.
- The evaluated viewpoints need to be adjusted for the actual pose of the object on the scanning table.
- Ignoring this causes **redundant scanning** runs and **occlusions**, preventing a complete object coverage.
- An initial pose estimate is required to transform the generated viewpoints

Previous Work

Monocular Pose Estimation with Local Color Histograms (Tjaden et al.)

- Prerequisite background and object knowledge
- Time expensive

Cluttered Scene Object Pose Estimation using PoseCNNs (Xiang et al.)

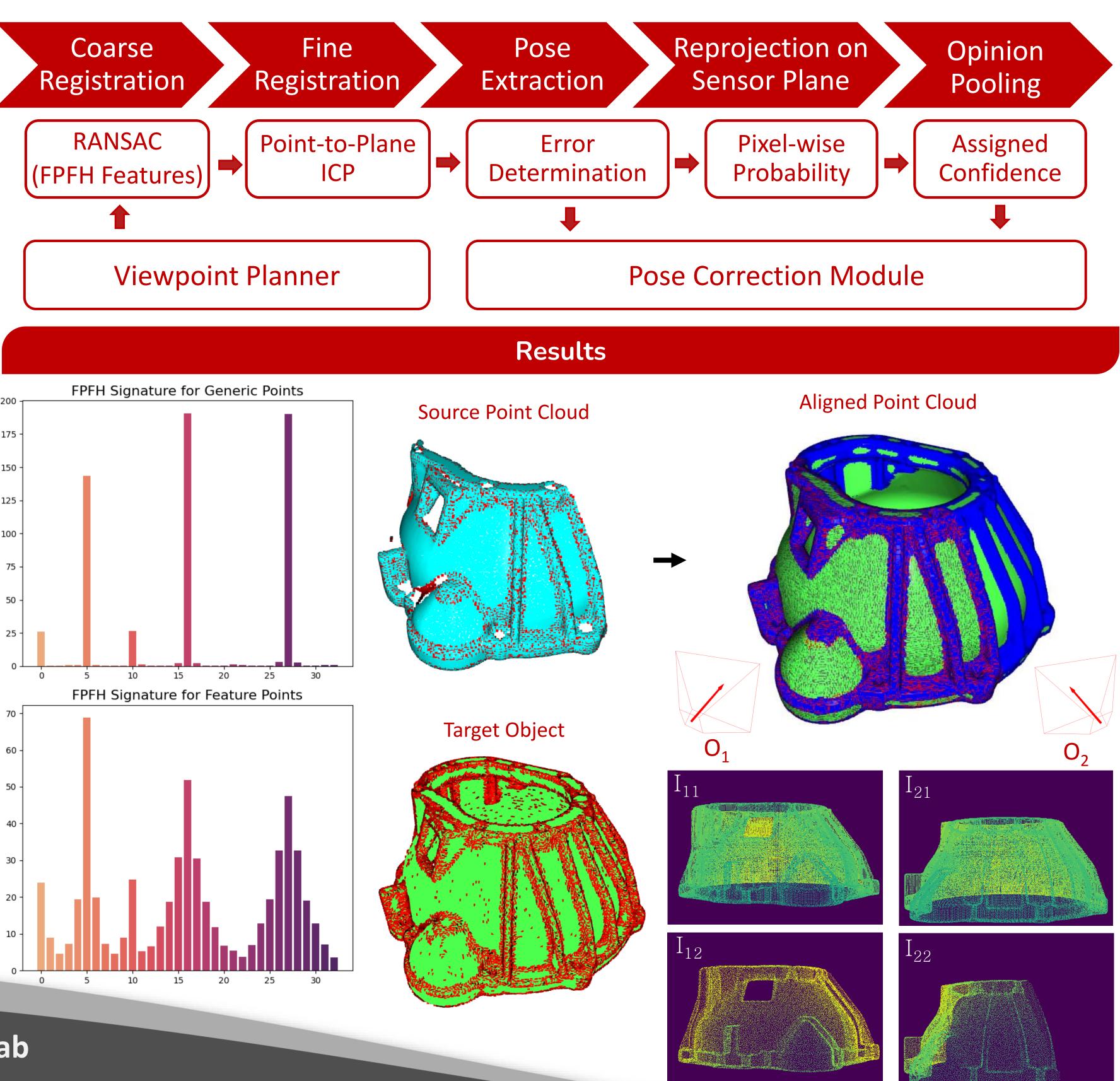
- Low accuracy threshold of the estimated poses
- Prone to local minimums

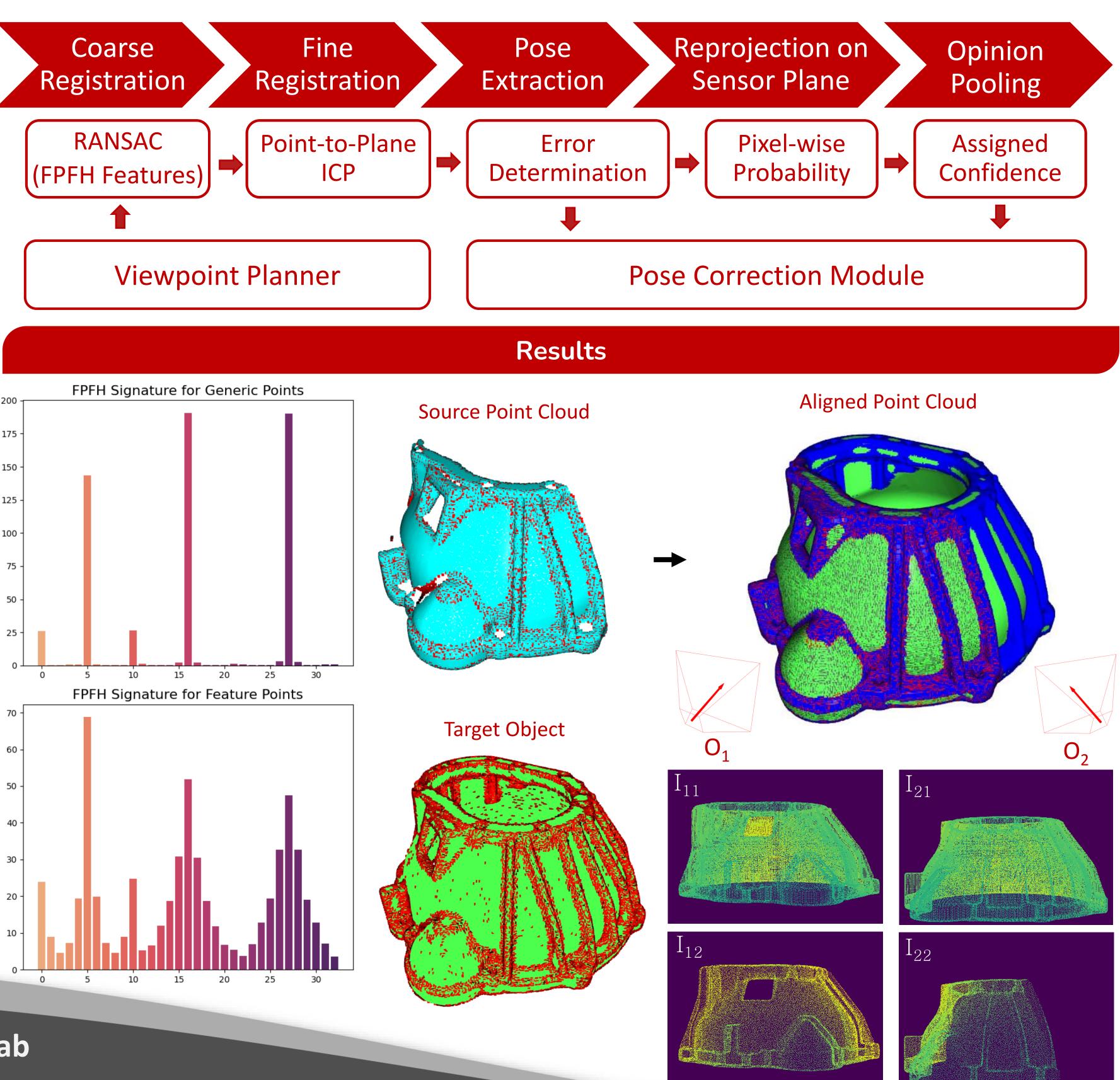
Quality Analysis of Matched Point Clouds of Objects (Bogoslavsky et al.)

- Developed for scene rich LiDAR scans
- Highly sensitive to sensor noise

Algorithm

- **Coarse Transform** using Fast Point Feature Histogram of the down-sampled cloud, provided to Random Sample Consensus based alignment module.
- Fine Registration using Point-to-Plane ICP with coarse transform warm start.
- **Pose Extraction** from the resulting transform used to correct the viewpoints.
- **Reprojection of clouds** on image planes at transformed origins to get four depth maps. **opinion pooling** to get a confidence metric.
- Pixel-wise probability calculation followed by

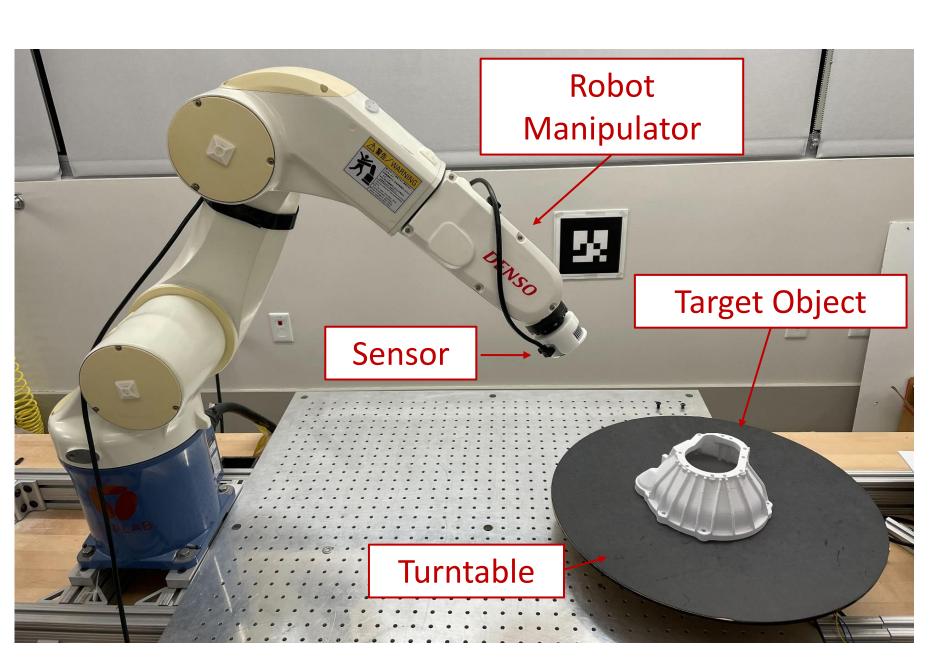


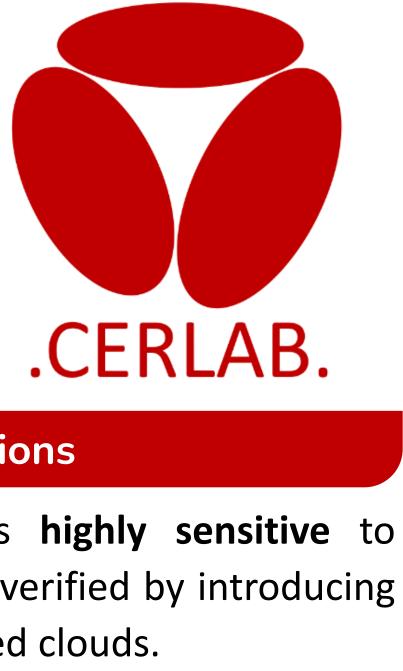


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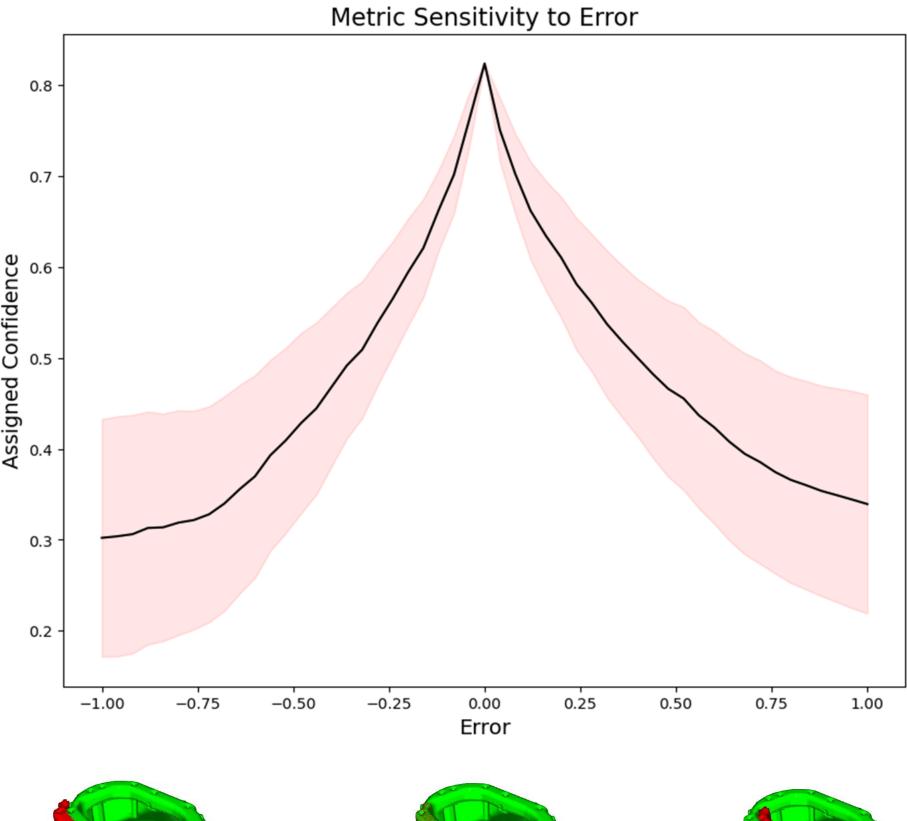
Proposed Methods

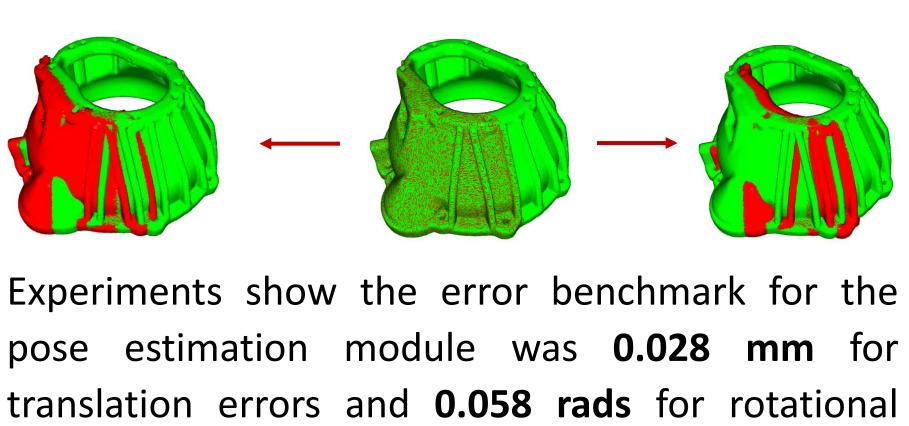




Conclusions

The Confidence Metric is highly sensitive to alignment errors. This was verified by introducing synthetic error to the aligned clouds.





pose error.



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